

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/789,764  
Filing Date: February 27, 2004  
Applicant: Boisseau, et al.  
Group Art Unit: 1709  
Examiner: Christine T. Mui  
Title: TEST METHOD FOR DETERMINING ETCH  
PERFORMANCE OF A COATED SUBSTRATE  
Attorney Docket: IN-5597 (HDP 0906S-000446/US)

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Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE AFTER FINAL**

Sir:

In response to the Office Action mailed November 28, 2007, please consider the remarks set forth below.

**Remarks** begin on page 2 of this paper.